

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

TRADE ME lectronic Version v18 Stylesheet Version v18.0

> Title of Invention

CONTINUOUS FLOW DEPOSITION SYSTEM

Application Number:

10/604502

Confirmation Number:

1501

First Named Applicant:

Piero Sferlazzo

Attorney Docket Number: FLU-001

Search string:

(4058430 or 6458416 or 6503330 or

20010007244 or 20020195056 or 20030023338

or 20030098372).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	, Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
W	1	4058430	1977-11-15	Suntola, et al.		156	611
	2	6458416	2002-10-01	Derderian, et al.	B1	427	301
V	3	6503330	2003-01-07	Sneh, et al.	B1	118	715

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
W	1	20010007244	2001-07-12	Matsuse	A1	118	719
	2	20020195056	2002-12-26	Sandhu, et al.	A1	118	719
	3	20030023338	2003-01-30	Chin, et al	A1	700	121
Y	4	20030098372	2003-05-29	Kim	A1	239	548

Signature

Examiner Name	Date
LAPLA MOCKE	11/15/04

PTO/SB/08b (08-03)
Approved for use through 06/30/2005. OMB 0651-003)
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE
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Substitute for for	rm 1449B/PTO				Complete if Known	`	
				Application Number	10/604,502		
	MATION E			Filing Date	7/25/2003		
STATE	MENT BY	APPLIC	CANT	First Named Inventor	SFERLAZZO	·	
				Art Unit	Not yet assigned		
(U:	se as many sheets	as necessary)		Examiner Name	Not yet assigned		
Sheet	1	of	1	Attorney Docket Number	FLU-001		

		NON PATENT LITERATURE DOCUMENTS	,
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
W	C1	MARTIN, High K Gate Dielectrics, LETI Annual Research Review- HighK Gate Dielectrics, June 15, 2001, Pgs. 1-16.	
	C2	NIINISTO, Oxide Thin Films By ALD For Advanced Applications, Helsinki University of Technology, Espoo, Finland, August 19th-24th 2002	
$\sqrt{}$	C3	SUNTOLA, ET AL., Atomic Layer Epitaxy, Ann. Re. Mater. Sci., 1985, Pgs. 177-195, Annual Reviews Inc., Espoo, Finland.	

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Examiner Signature APLA MOOPE Date Considered 11/15/04

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Application Number:

10/604502

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1501

First Named Applicant:

Piero Sferlazzo

Attorney Docket Number: FLU-001PC

Search string:

(6541353 or 6576062).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
W		6541353	2003-04-01	Sandhu, et al.	B1	438	478
	2	6576062	2003-06-10	Matsuse	B2	118	719

Signature

Examiner Name	Date
L KAPLA MOORE	11/15/04



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1501

First Named Applicant:

Piero Sferlazzo

Attorney Docket Number: FLU-001

Search string:

(6319553).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
M = 1	6319553	2001-11-20	McInerney, et al.	B1	427	250

Signature

Examiner Name	Date
LEATLA MOGRE	11/18/04

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PTO/SB/08a (08-03)

Approved for use through 07/31/2006. OMB 0651-0031

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Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Co	emplete if Known
Application Number	10/604,502
Filing Date	7/25/2003
First Named Inventor	SFERLAZZO
Art Unit	1763
Examiner Name	Not Yet Assigned
Attorney Docket Number	FILLOOI

Examiner	Cite	Document Number	U. S. PATENT Publication Date	Name of Patentee or	T
nitials*	No.1	Number-Kind Code ² (f known)	MM-DD-YYYY	Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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	_A2	US- 5,338,362	08/16/1994	Imahashi	/
	A3	^{US-} 5,527,731	06/18/1996	Yamamoto, et al.	
1/	A4	^{US-} 2002/0100418 A1	08/01/2002	Sandhu, et al.	
<u> </u>	A5	us- 2003/0059538 A1	03/27/2003	Chung, et al.	
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Examiner	Cite	Foreign Patent Document	Publication Date	Name of Patentee or	Pages Columns Lines	П
Initials*	No.'	Country Code ³ Number ⁴ Kind Code ⁵ (if known)	MM-DD-YYYY	Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages	T ⁶
\mathcal{W}	B1	WO 01/17692 A1	03/15/2001	ASM America, Inc.	or Relevant Figures Appear	\supset
	B2	EP 06279182	¥	Mitsubishi Heavy		\vdash
A	В3	DE 10141084 AI	11/28/2002	Infineon Technologies		\dashv
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'EXAMINER:	Initial if reference considered, whether or not citation is in conference in its angle of the conference considered whether or not citation is in conference considered.		111/10/09	/-

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This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.